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July 6, 2004

**Receiver:** Examiner EASTHOM (USPTO Central Fax)

**FAX #:** 703-872-9306

**Sender:** Haruo Yawata  
**Our Ref. No.:** ALPSP128

**Application No.:** 10/617,622

**Re:** Response to Restriction Requirement

**Pages Including Cover Sheet(s):** 03

**MESSAGE:**

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE****PATENT**

In re application of: Taguchi et al.

Attorney Docket No.: ALPSP128

Application No.: 10/617,622

Examiner: Easthom, K.

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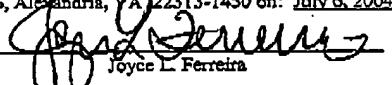
Filing Date: July 10, 2003

Group: 2832

JUL 06 2004

**Title: RESISTOR SUBSTRATE WITH  
RESISTOR LAYER AND ELECTRODE LAYER  
AND MANUFACTURING METHOD THEREOF****OFFICIAL****CERTIFICATE OF FACSIMILE TRANSMISSION:**

I hereby certify that this correspondence is being transmitted by facsimile to the United States Patent and Trademark Office, Commissioner for Patents, Attn: Examiner Easthom, Fax No. 703-872-9306, Alexandria, VA 22313-1450 on: July 6, 2004.

Signed: 

Joyce L. Ferreira

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Restriction Requirement dated June 10, 2004 Applicant hereby elects, without traverse, group I, claims 1-6, drawn to a resistor, to prosecute in the above-identified patent application.

If any fees are due in connection with the filing this Response to Restriction Requirement, the Commissioner is hereby authorized to charge such fees to Deposit Account 500388 (Order No. ALPSP128).

Respectfully submitted,  
BEYER WEAVER & THOMAS, LLP

  
Haruo Yawata  
Limited Recognition under 37 C.F.R. §10.9(b)

P.O. Box 778  
Berkeley, CA 94704-0778

**BEFORE THE OFFICE OF ENROLLMENT AND DISCIPLINE  
UNITED STATES PATENT AND TRADEMARK OFFICE**

**LIMITED RECOGNITION UNDER 37 CFR § 10.9(b)**

Mr. Haruo Yawata is hereby given limited recognition under 37 CFR § 10.9(b) as an employee of Beyer Weaver & Thomas, LLP to prepare and prosecute patent applications wherein the patent applicant is the client of Beyer Weaver & Thomas, LLP, and the attorney or agent of record in the applications is a registered practitioner who is a member of Beyer Weaver & Thomas, LLP. This limited recognition shall expire on the date appearing below, or when whichever of the following events first occurs prior to the date appearing below: (i) Mr. Haruo Yawata ceases to lawfully reside in the United States, (ii) Mr. Haruo Yawata's employment with Beyer Weaver & Thomas, LLP ceases or is terminated, or (iii) Mr. Haruo Yawata ceases to remain or reside in the United States on an H-1 visa.

This document constitutes proof of such recognition. The original of this document is on file in the Office of Enrollment and Discipline of the U.S. Patent and Trademark Office.

Expires: August 28, 2004



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Harry I. Moatz  
Director of Enrollment and Discipline